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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tetsuya IKUTA et al.**

Group Art Unit: **2814**

Application Number: **10/809,809**

Examiner: **Thao X. Le**

Filed: **March 26, 2004**

Confirmation Number: **7816**

For: **SEMICONDUCTOR MANUFACTURING METHOD FOR
IMPROVING CARRIER MOBILITY AND REDUCING LEAK
CURRENT (AS AMENDED)**

Attorney Docket Number: **042278**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.111

Mail Stop: Amendment

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

June 21, 2006

Sir:

This paper is filed in response to the Office Action dated May 1, 2006.

Remarks/Arguments begin on page 2 of this paper.